

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Ye et al.

Serial No. 10/078,720

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For: **METHOD AND APPARATUS FOR
CUTTING A SUBSTRATE USING
LASER IRRADIATION**

Attorney's Docket No.: 4795-004



Group Art Unit 1725

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Information Disclosure Statement

Sir:

Attached hereto is an information disclosure statement (PTO-1449). This IDS is being submitted before any action on the merits. As such, no fee is required. However, if fees are required, please deduct from our Deposit Account No. 18-1167.

Respectfully submitted,

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I HEREBY CERTIFY THAT THIS DOCUMENT IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE ON THE DATE INDICATED, AS FIRST CLASS MAIL, POSTAGE PREPAID, IN AN ENVELOPE ADDRESSED TO: **BOX PATENT APPLICATIONS, COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.**

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